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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Patent Application of

SUGIHARA ET AL.

Atty. Ref.: 1035-616

Serial No. Unknown

TC/A.U.: Unknown

Filed: December 16, 2005

Examiner: Unknown

For: SEMICONDUCTOR DEVICE, MANUFACTURING METHOD THEREOF,
AND ELECTRONIC DEVICE

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December 16, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT

As suggested by 37 C.F.R. 1.97, the undersigned attorney brings to the attention of the Patent and Trademark Office the references listed on the attached form PTO/SB/08a. Copies of the listed foreign patent documents and articles are attached.

This is not to be construed as a representation that a search has been made or that no better prior art exists, or that a reference is relevant merely because cited.

The Examiner is requested to initial the attached form PTO/SB/08a and to return a copy of the initialed document to the undersigned as an indication that the attached references have been considered and made of record.

Respectfully submitted,

NIXON & VANDERHYE P.C.

By:



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INFORMATION DISCLOSURE CITATION

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SERIAL NO.

1035-616

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APPLICANT

SUGIHARA ET AL.

FILING DATE

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December 16, 2005

Unknown

(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

							TRANSLATION	
DOCUMENT			DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
		2003-86808	3/2003	JP			ABST	
		8-264794	10/1996	JP			ABST	
		2002-289859	10/2002	JP			ABST	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

	International Search Report for PCT/JP2004/008322 dated 21 September 2004 (English and Japanese).
	Joseph et al; <i>p-Type Electrical Conduction in ZnO Thin Films by Ga and N Codoping</i> , Jpn. J. Appl. Phys. Vol. 38 (1999), Part 2, No. 11A, 1 November 1999, pp. 1205-1207.
	Minegishi et al., <i>Growth of p-type Zinc Oxide Films by Chemical Vapor Deposition</i> , Jpn. J. Appl. Phys., Vol. 36 (1997), Part 2, No. 11A, 1 November 1997, pp. 1453-1455.

*Examiner

Date Considered

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.